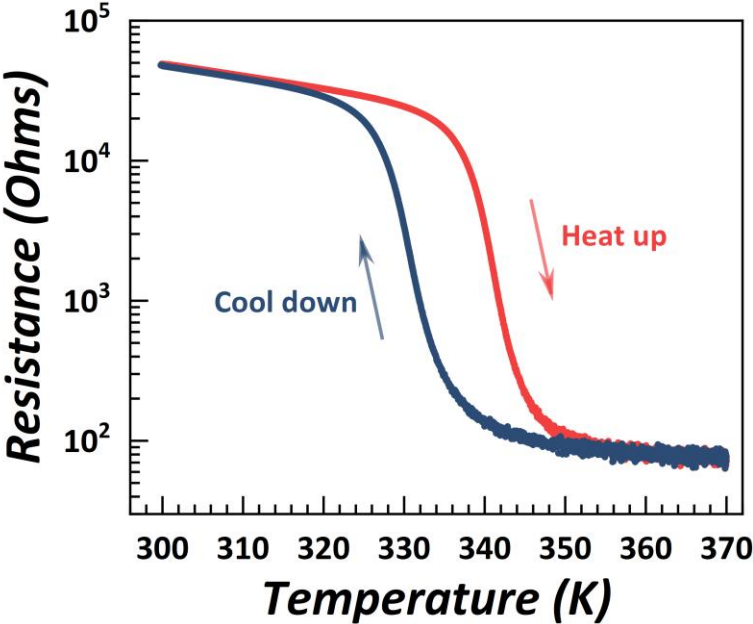


Supplemental Document



Supplemental figure. Temperature-dependent electrical measurement of the insulator-to-metal transition for the VO₂ thin film deposited by ALD.